

Notice of References Cited	Application/Control No. 09/918,537	Applicant(s)/Patent Under Reexamination NAKAGAWA ET AL.	
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U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-5,953,338	09-1999	Ma et al.	370/395.21
	B	US-6,744,767	06-2004	Chiu et al.	370/395.21
	C	US-6,205,154	03-2001	Schmidt et al.	370/458
	D	US-2002/0059408	05-2002	Pattabhiraman et al.	709/223
	E	US-6,785,285	08-2004	Romana et al.	370/395.51
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

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	N					
	O					
	P					
	Q					
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	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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	V	
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